S/N 10/623,788 **PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Leonard Forbes et al.

Examiner: Pamela E. Perkins

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STRAINED SEMICONDUCTOR BY FULL WAFER BONDING

## **RESPONSE UNDER 37 CFR § 1.111**

ail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

This responds to the Office Action dated on August 9, 2007.